

ITW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
)
Nobuo ISHII et al.) Group Art Unit: 1763
)
Serial No.: 10/519,775) Examiner: Rakesh Kumar Dhingra
)
Filed: December 29, 2004)
) Confirmation No.: 7307
For: PLASMA PROCESSING)
APPARATUS AND)
CONTROLLING METHOD)
THEREFOR)
)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

REPLY TO OFFICE ACTION

In reply to the Office Action mailed June 11, 2007, please amend the
above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks/Arguments follow the amendment sections of this paper.